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AMENDMENT UNDER 37 C.F.R. § 1.116
EXPEDITED PROSECUTION - GROUP ART UNIT 1762

03500.014241

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

13 Hrs
DP not entered
9/10/04

In re Application of:)	
	:	Examiner: B. Talbot
NOBUHIRO ITO)	
	:	Group Art Unit: 1762
Application No.: 09/505,627)	
	:	
Filed: February 16, 2000)	
	:	
For: MANUFACTURING METHOD OF)	
ELECTRON BEAM APPARATUS	:	
AND SPACER, AND ELECTRON)	
BEAM APPARATUS	:	August 19, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Mail Stop AF

AMENDMENT AFTER FINAL REJECTION

Sir:

A. Introductory Comments

In response to the final Office Action dated May 20, 2004, please amend the application as follows and consider the following remarks.